

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q63075

Kazunobu FUJIKAWA, et al.

Appln. No.: 09/763,194

Group Art Unit: 3742

Confirmation No.: 3832

Examiner: Maria Alexandra ELVE

Filed: February 20, 2001

For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING , AND AN ELECTRODE FOR SURFACE DISCHARGE PROCESSING

**NOTICE OF APPEAL**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the final Office Action dated September 1, 2009.

The USPTO is directed and authorized to charge the statutory fee of \$540.00 and all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: December 1, 2009